

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants	:	Hideo SHITE	Confirmation No.: 6783
Serial No.	:	10/538,727	
Filed	:	June 13, 2005	
Art Unit	:	1792	
Examiner	:	Yewebdar T. Tadesse	
For	:	COATING PROCESS APPARATUS AND COATING FILM FORMING METHOD	

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed November 26, 2008 please amend the above-identified application as set forth below and consider the following arguments.

Amendments to the Claims begin on page 2.

Remarks begin on page 6.